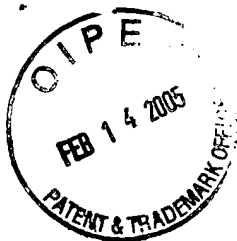


IFW



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

JIHONG CHEN ET AL.

Serial No. 10/667,012 (TI-35554)

Filed September 19, 2003

For: A SEMICONDUCTOR DEVICE HAVING AN ANGLED COMPENSATION
IMPLANT AND METHOD OF MANUFACTURE THEREFOR

Art Unit 2815

Examiner Edward Joseph Wojciechowicz

Customer No. 23494

Mail Stop Amendment
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATE OF MAILING OR TRANSMISSION UNDER 37 CFR 1.8

I hereby certify that the attached document is being deposited with the United States Postal Service with sufficient postage for First Class Mail in an envelope addressed to Director of the United States Patent and Trademark Office, P.O. Box 1450,, Alexandria, VA 22313-1450 or is being facsimile transmitted on the date indicated below:

2-11-05

Jay M. Cantor, Reg. No. 19,906

AMENDMENT UNDER 37 CFR 1.111

Sir:

Responsive to the Office action dated November 16, 2004, please amend the above identified application as follows: